	Туре	L #	Hits	Search Text	DBs	Time Stamp
1	BRS	L1	46958	silicon adi nitride	USPAT; US-PGPUB	2002/05/31 14:42
2	BPS	L2	873	1 with tantalum adj oxide	USPAT; US-PGPUB	2002/05/31 14:53
3	BPS	L3	4	2 and monos	USPAT; US-PGPUB	2002/05/31 14:54
4	BPS	L4	208	l with (bst or (barium adj strontium))	USPAT; US-PGPUB	- 1
5	BFS	L5	0	4 and monos	USPAT; US-PGPUB	2002/05/31 14:56
ó	BF.S	Lő	1	4 and mnos	USPAT; US-PGPUB	2002/05/31 14:54
7	BFS	ь7	0	, ,	USPAT; US-PGPUB	2002/05/31 14:57
8	BES	L8	18	. 2	USPAT; US-PGPUB	2002/05/31 14:57

	Туре	L #	Hits	Search Text	DBs	Time Stamp
1	BPS	L1	46958	silicon adj nitride	USPAT; US-PGPUB	2002/05/31 14:42
2	BRS	L2	873	9	USPAT; US-PGPUB	2002/05/31 14:53
3	BRS	L3	4	2 and monos	USPAT; US-PGPUB	
4	BFS	L4	208	<pre>1 with (bst or (barium adj strontium))</pre>	USPAT; US-PGPUB	
5	BF:S	L5	ı)	4 and menos	USPAT; US-PGPUB	2002/05/31 14:56
ΰ	BPS	L6	1	4 and mnos	USPAT; US-PGPUB	2002/05/31 14:54
7	BPS	L7	i)	, , ,	USPAT; US-PGPUB	2002/05/31 14:57
8	BFS	L8	18	• 3	USPAT; US-PGPUB	2002/05/31 14:57

	Docu	Document ID	Issue Date Pages	Pages	Title	Current OR	Current OR Current XRef	Inventor
	9) 10 1	ৰ চ এডৱাই হয়	121 ma 2 2 2 3 4	eg.	Semiconductor permony device having an insulating film and a trap film joined in a channel region	257/326	257/316; 257/324	Shimoji, Noriyuki
ं चं	T. 61.	6146904 A	FTT1) -	Method of making a two translator ferroelectric memory cell	438/3	438/240	Hsu, Sheng Teng et al.
22	0. 6048	6048738 A	20000411	×) ⊣	Mothod of making ferroelectric memory cell for VLSI RAM array	438/3	438/240;	Hsu, Sheng Teng et al.
7	20.00	5999444 A	41207	<u>ታ</u>	Nonvolatile seminonductor memory device and writing and erasing method of the same	365/185.02	365/185.18; 365/185.23	Fujiwara, Ichiro et al.
<u>د</u>	172 87	5737261 A	15 ÷ 0407	<u>«</u>	Non-volatile ferroelectric memory utilizing residual polarization of a ferroelectric film	365/145	257/295; 365/149	Taira, Shigenoku
9	Us S619051	isosı A	904005 54470409	1.1	Semiconductor nonvolatile memory cell	257/316	257/324; 257/325; 257/411	Endo, Nobuhiro